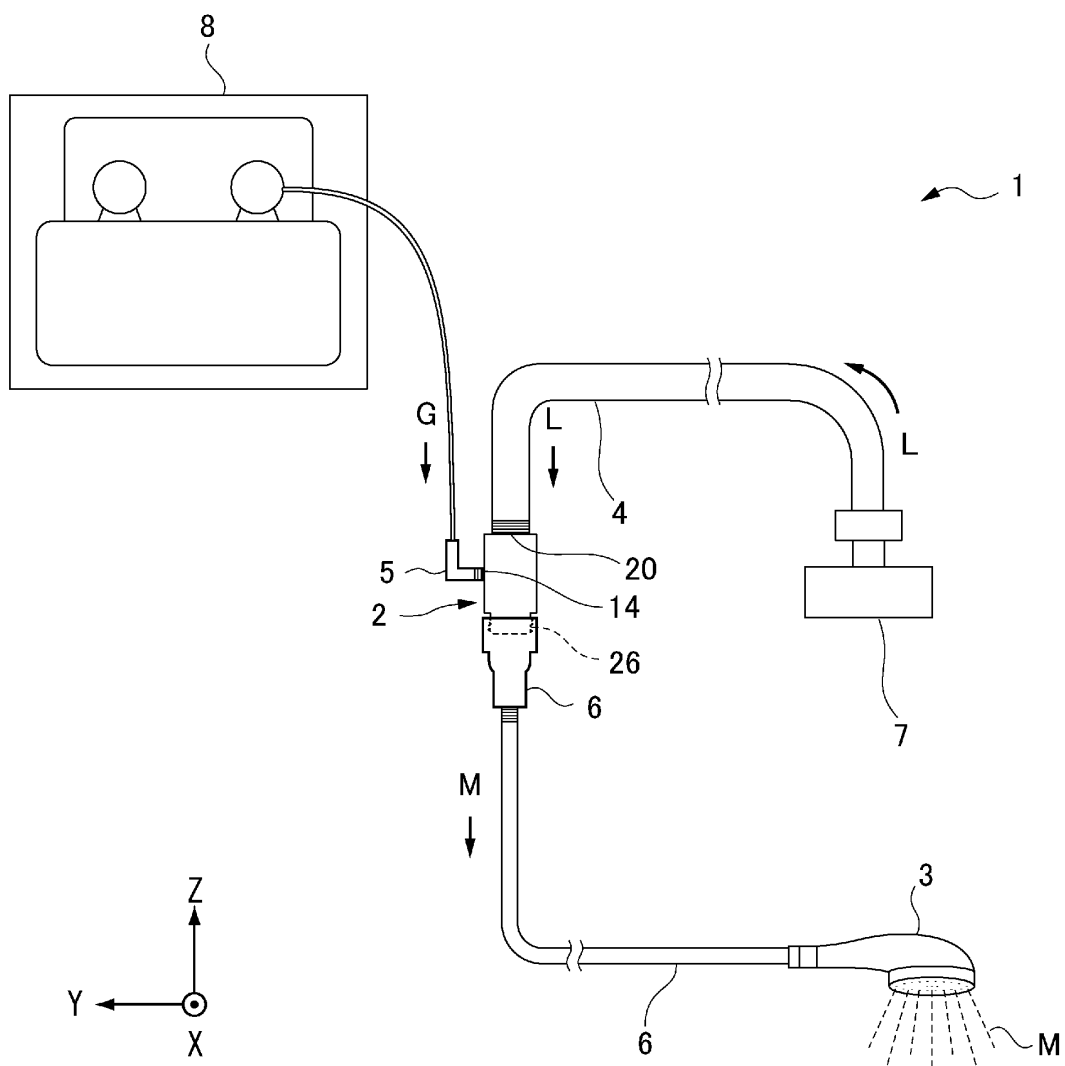


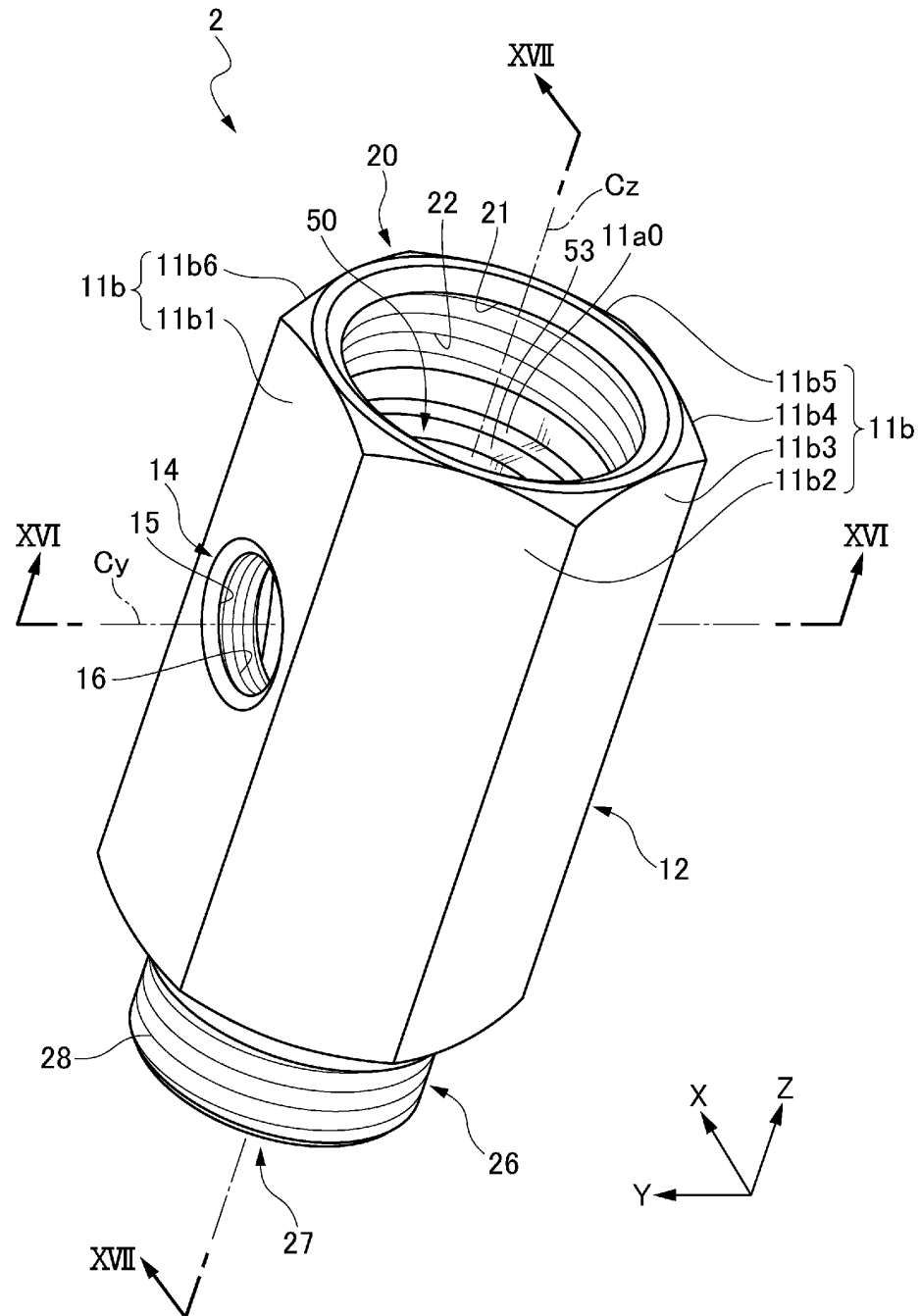
[図 1]

FIG. 1



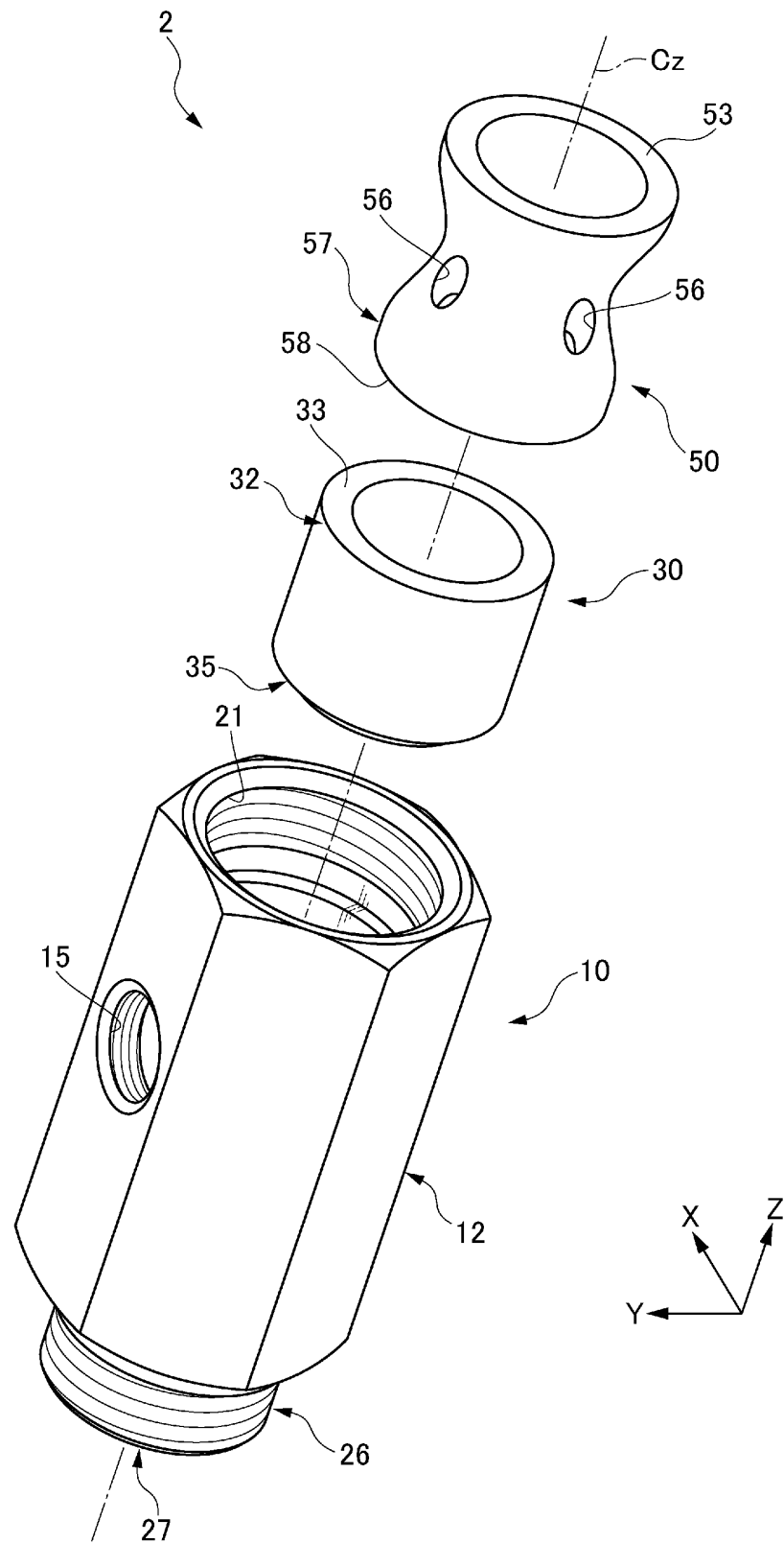
[図 2]

FIG. 2



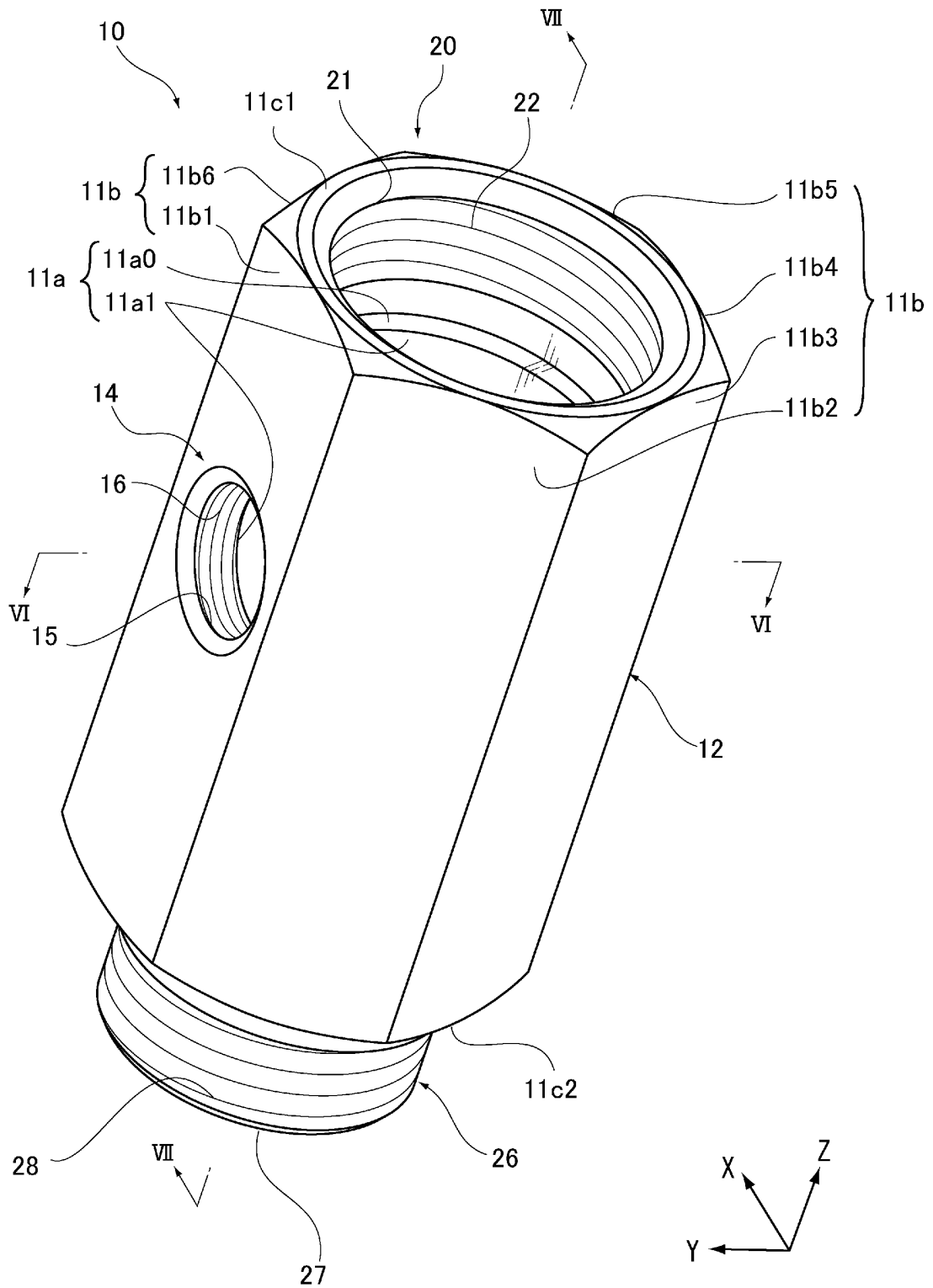
[図 3]

FIG. 3

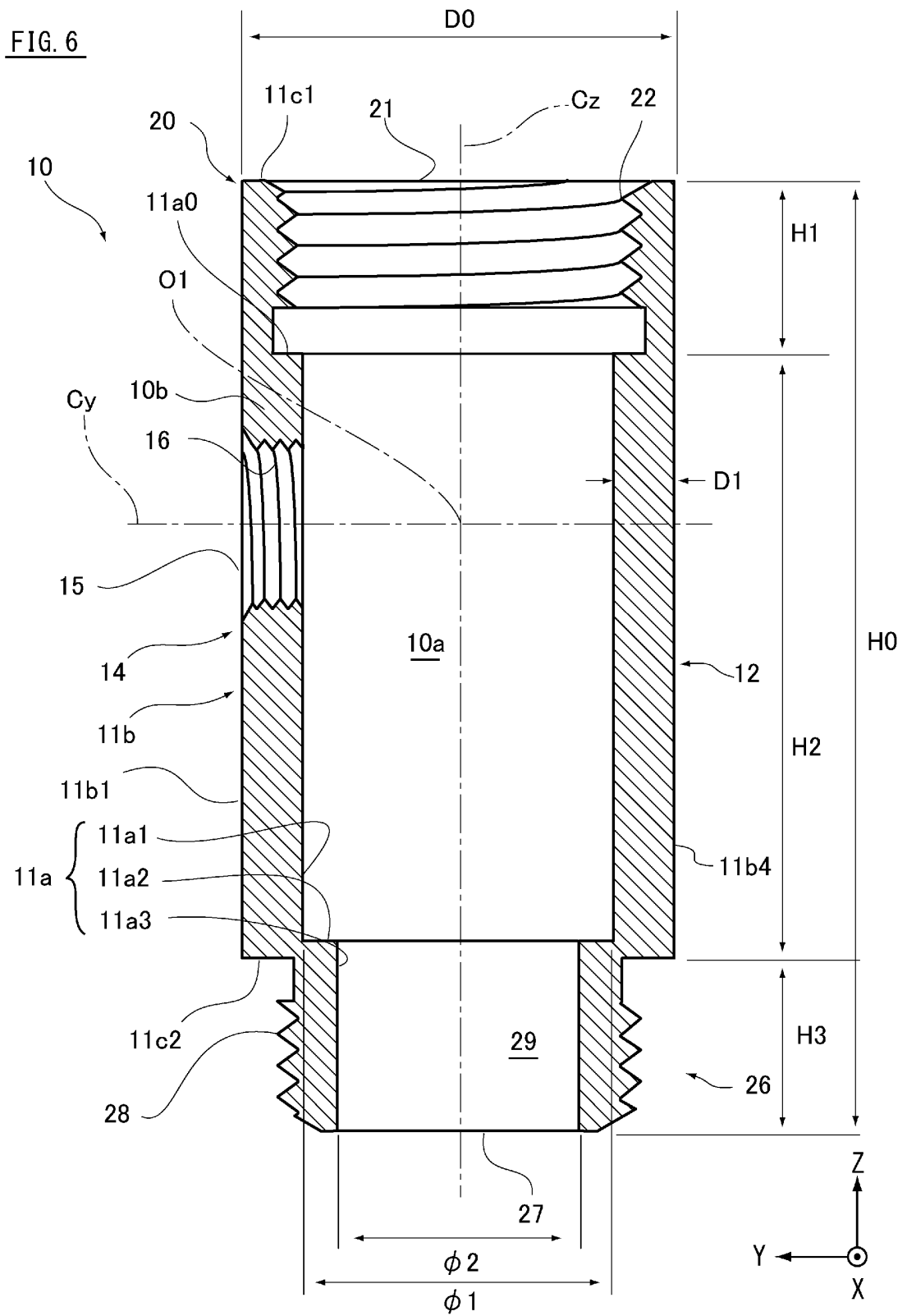


[図 4]

FIG. 4

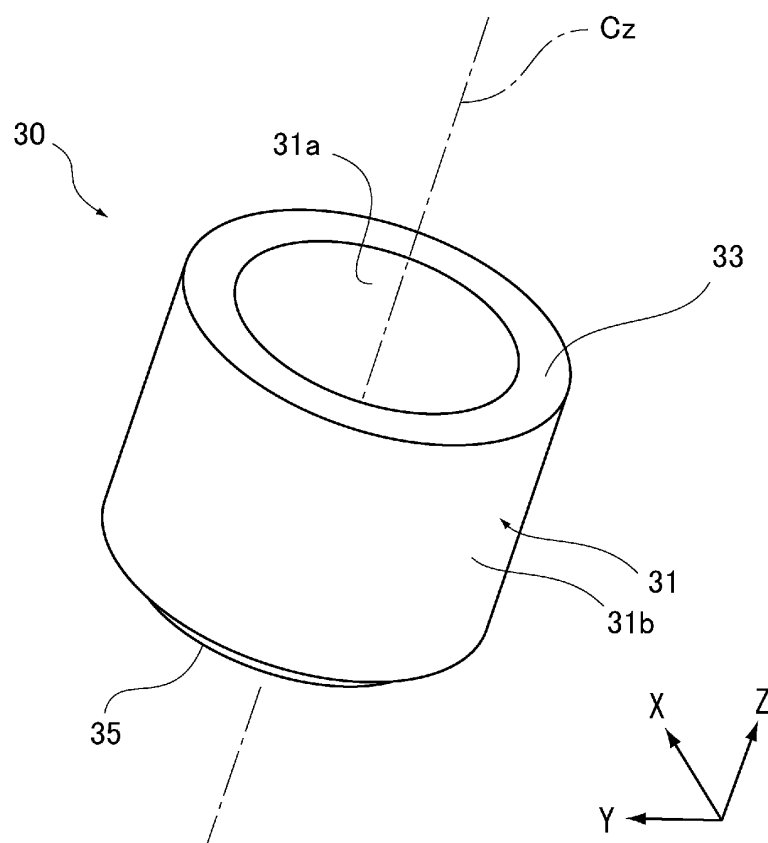


[図 6]



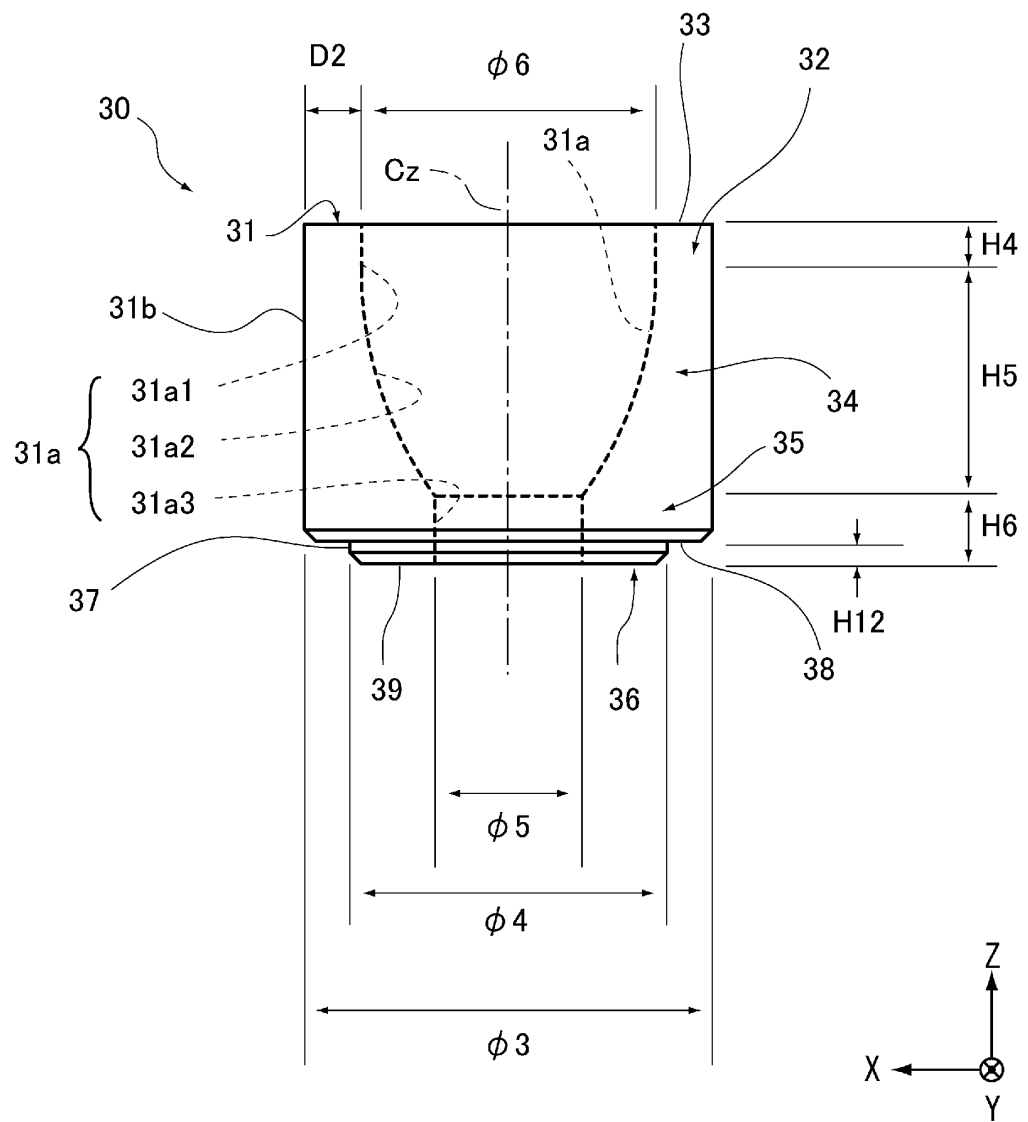
[図 8]

FIG. 8



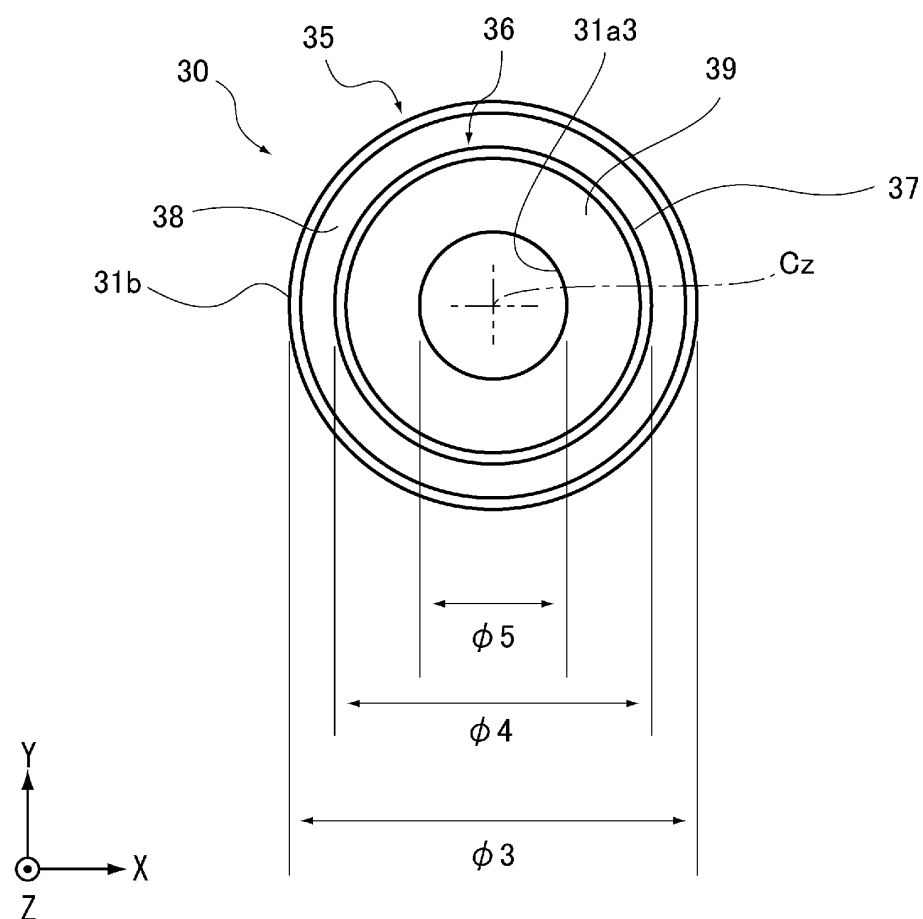
[図 9]

FIG. 9



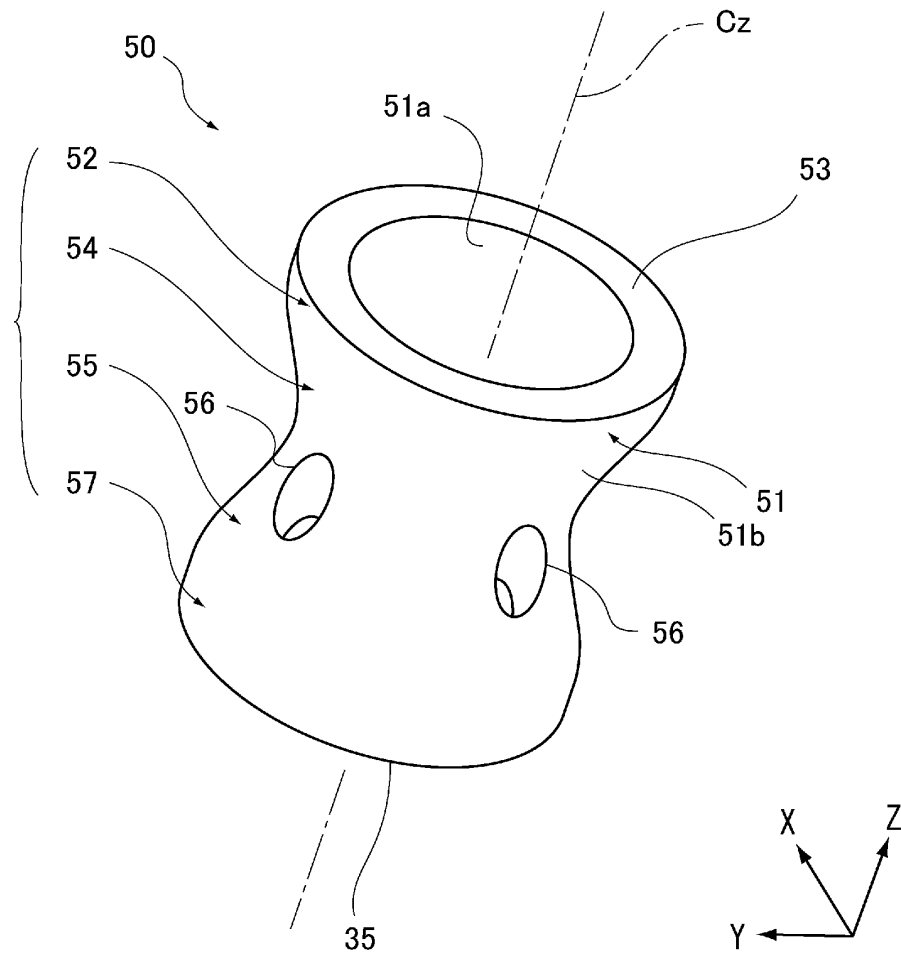
[図 10]

FIG. 10



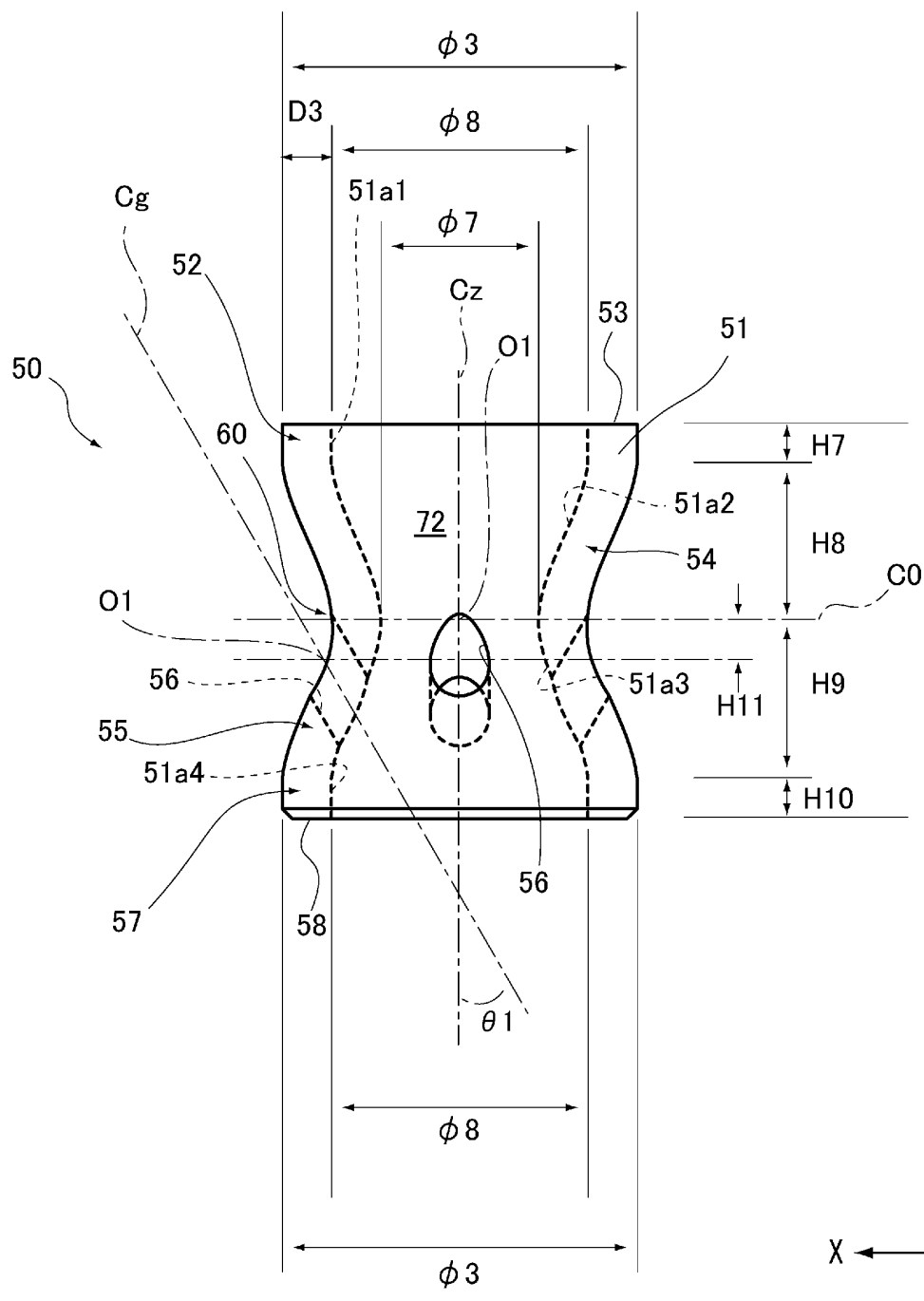
[図 11]

FIG. 11



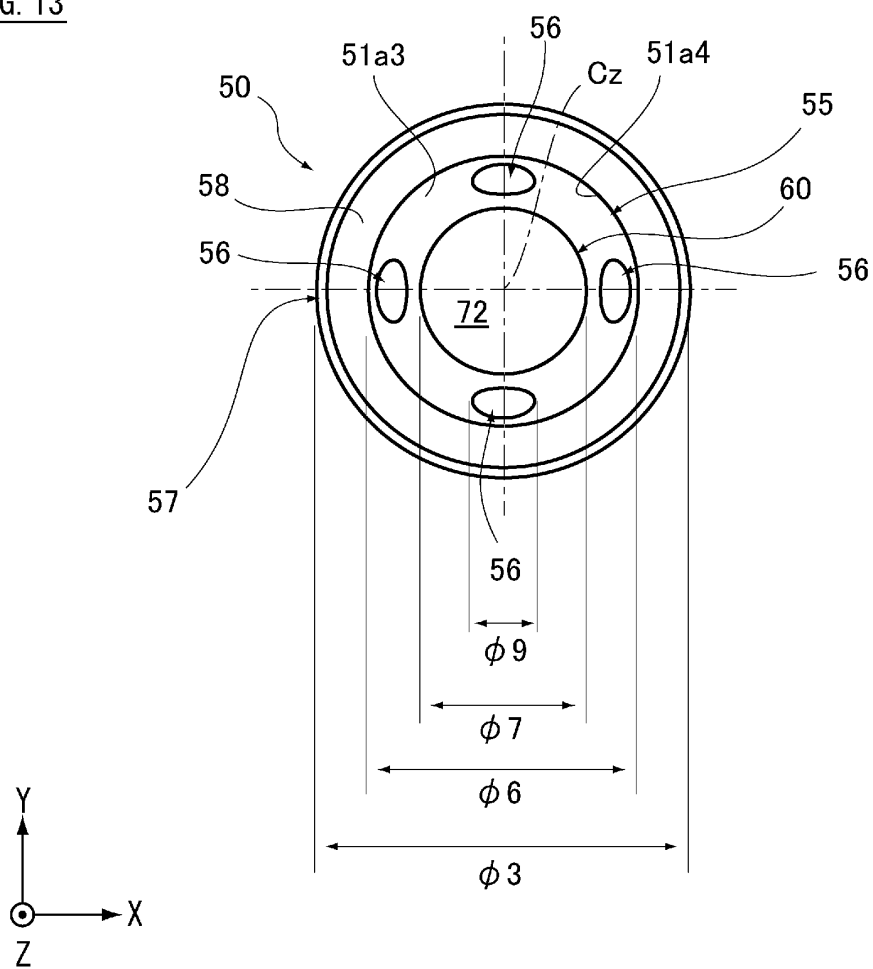
[図 12]

FIG. 12



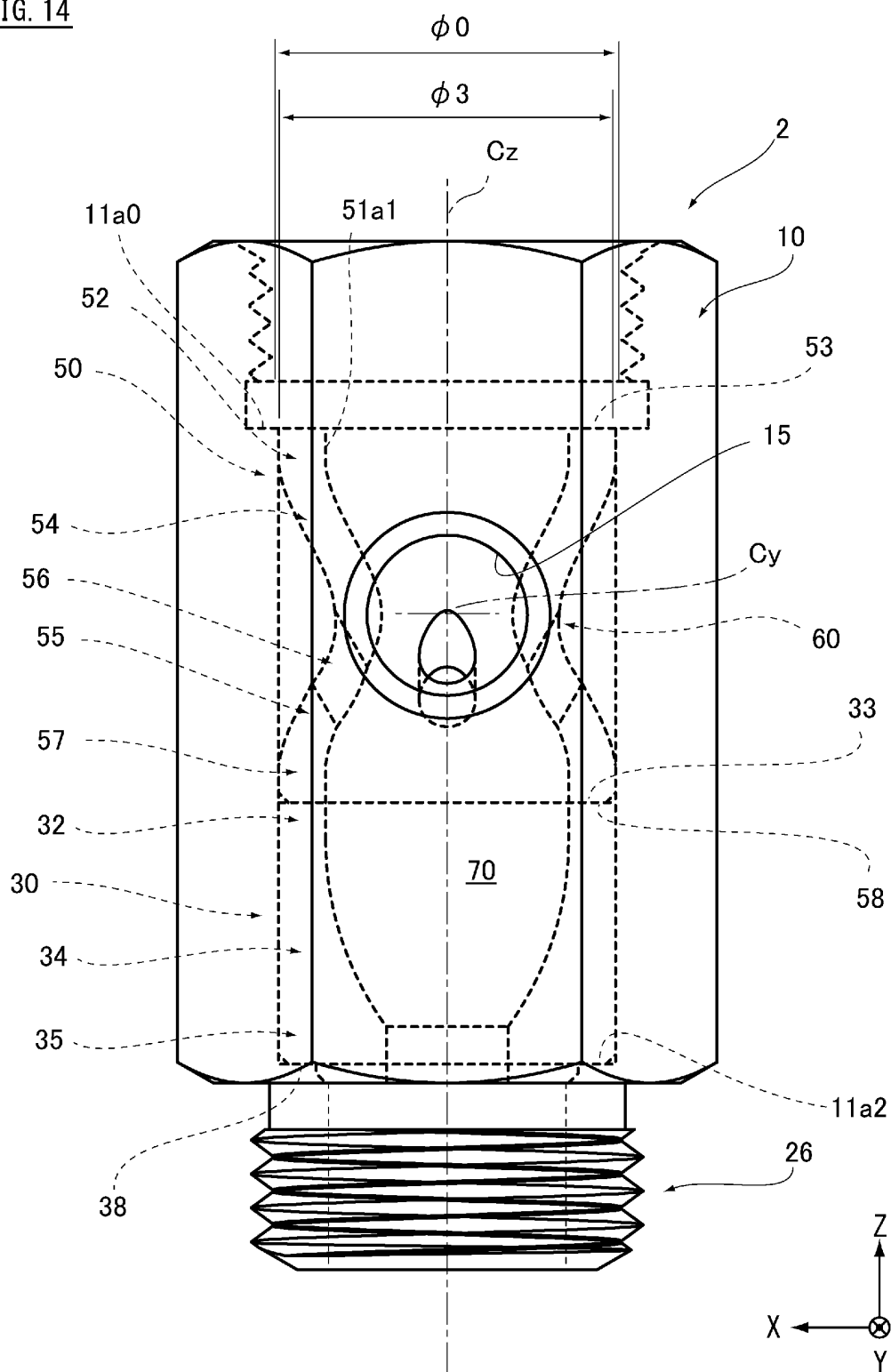
[図 13]

FIG. 13



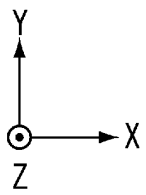
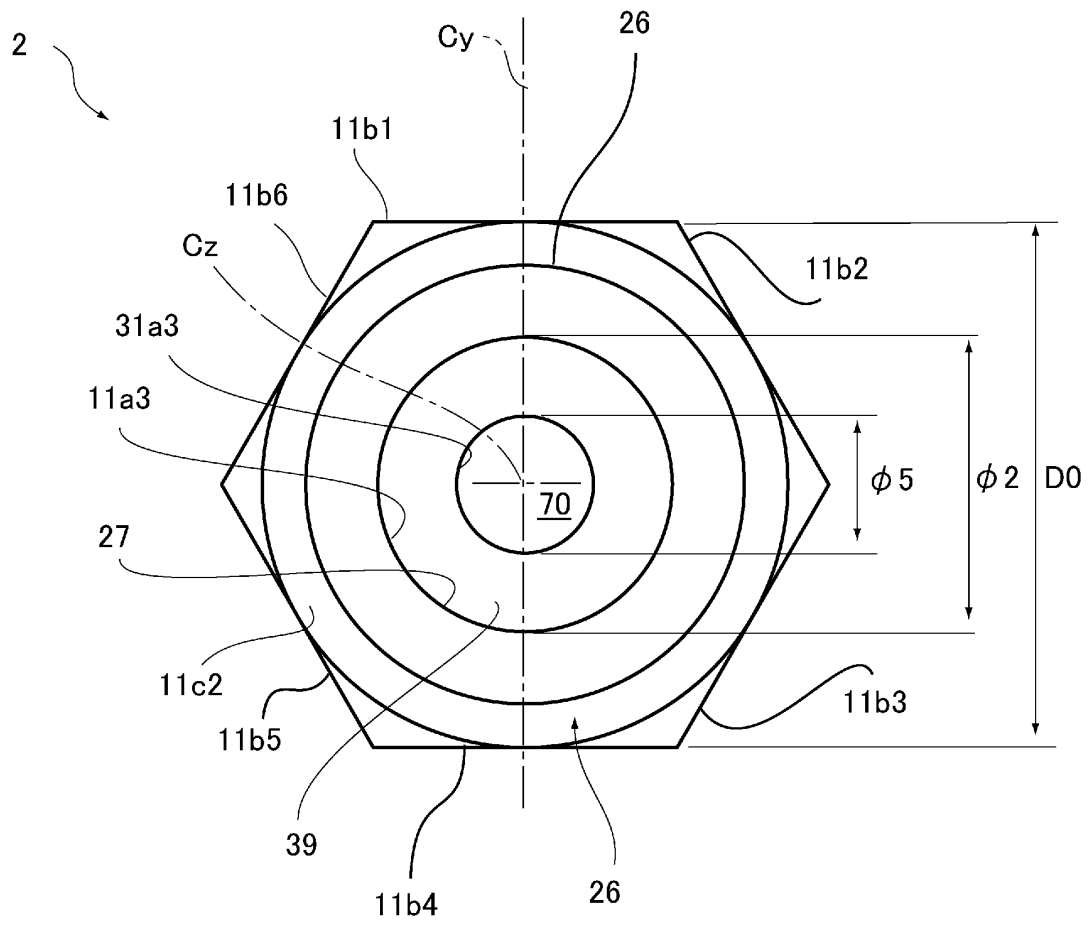
[図 14]

FIG. 14

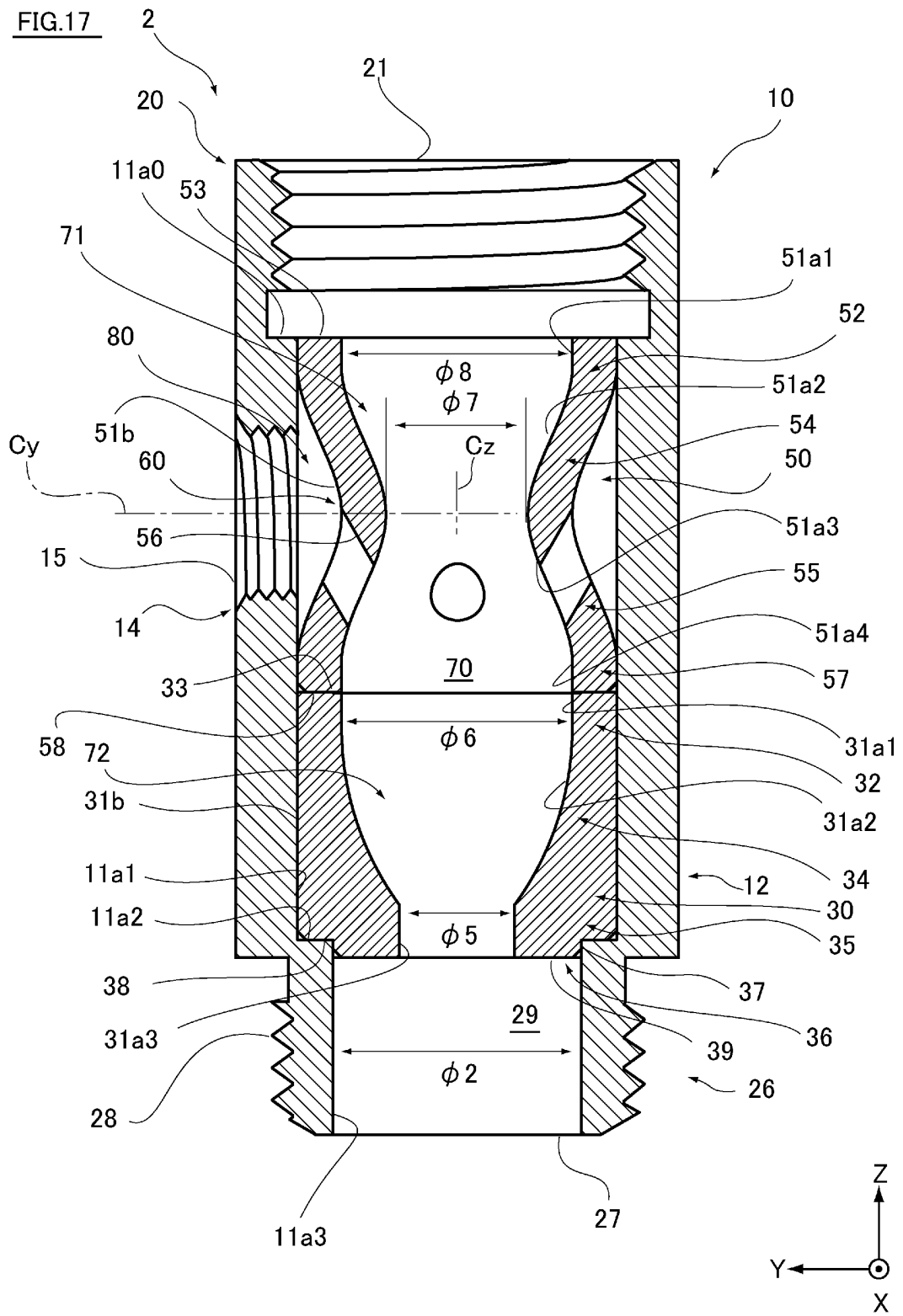


[図 15]

FIG. 15

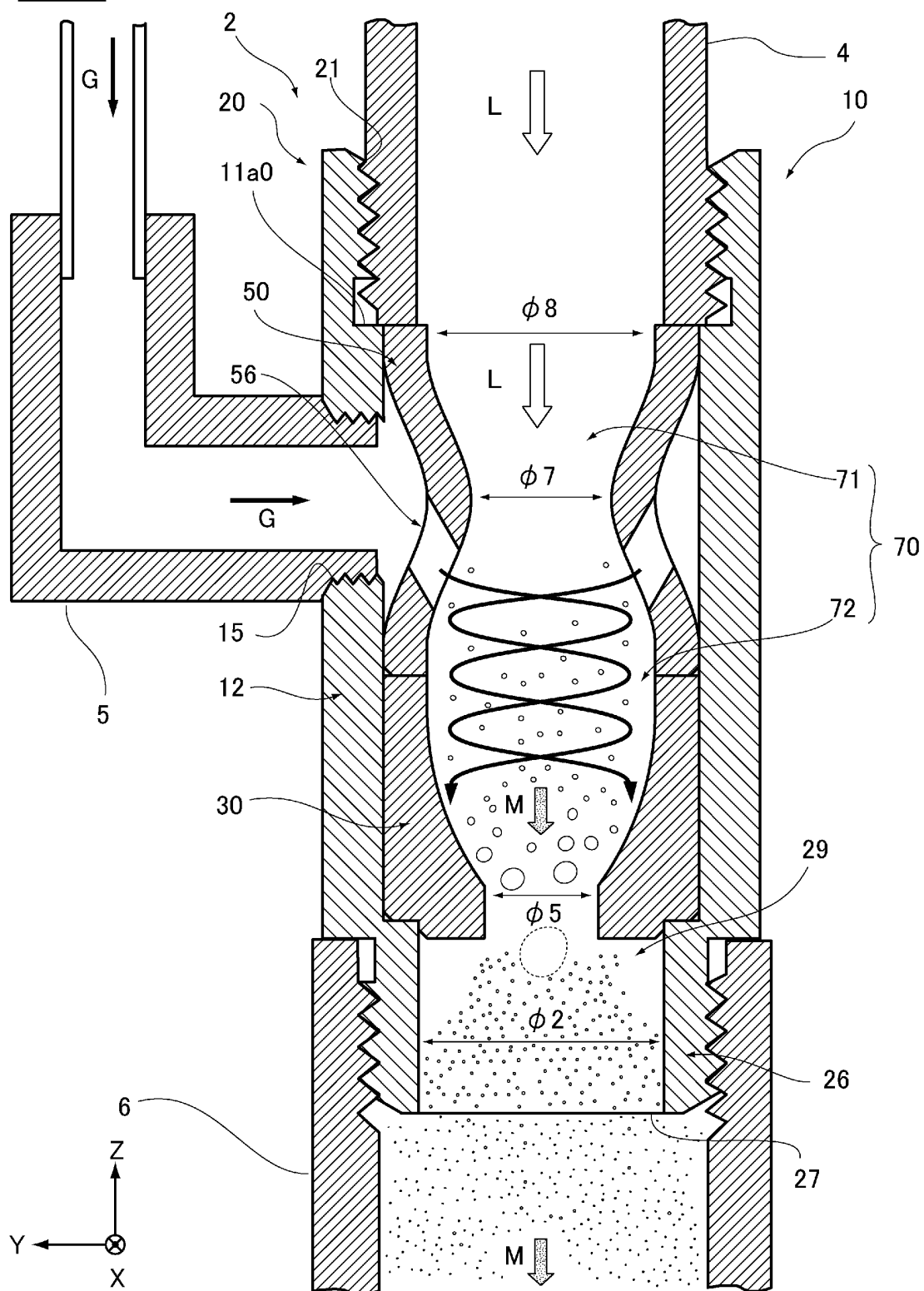


[図 17]



[図 18]

FIG.18



[図 19]

FIG.19

